

Figure 1. Schematic representation of the Cu electrochemical atomic layer deposition process.

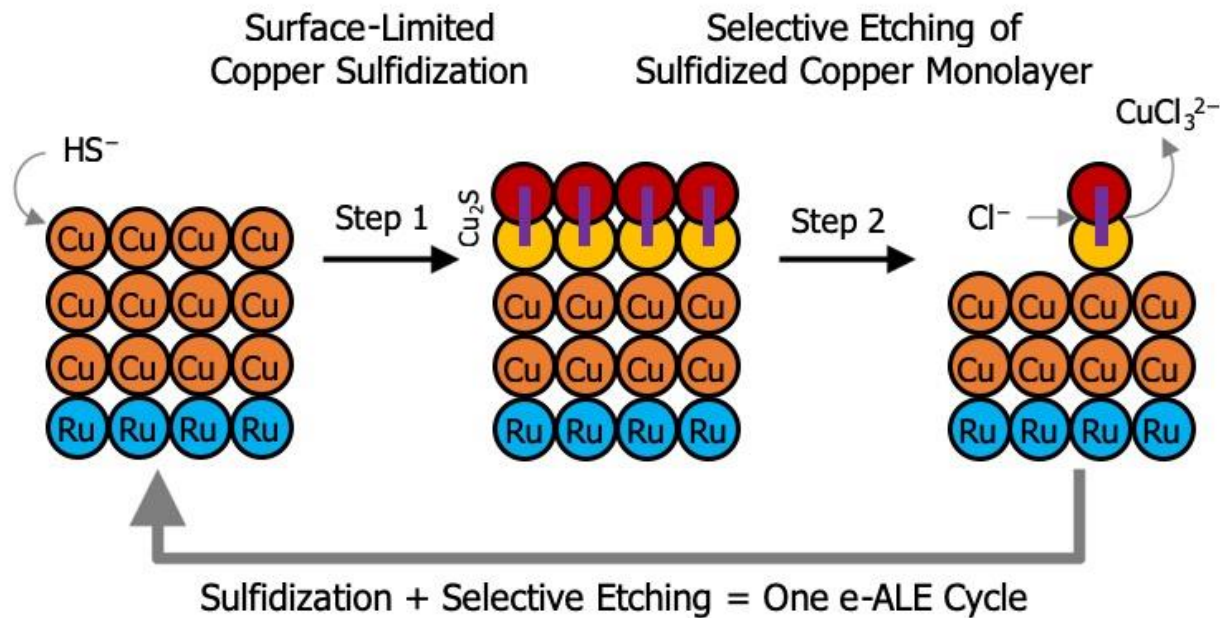


Figure 2. Schematic representation of the Cu electrochemical atomic layer etching process.